Ion Source and RFQ

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Fermilab Accelerator Advisory Committee May 10th – 12th, 2006

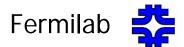
Thanks to Martin Stockli (SNS), Robert Welton (SNS), Jens Peters (DESY), and Jim Alessi (BNL) for providing study time on their respective ion sources.

Thanks to Chuck Schmidt and Henryk Piekarz for their contribution to ion source development

Thanks to Giorgio Apollinari, Gennedy Romanov, and Peter Ostroumov for providing slides and detailed information regarding the RFQ.

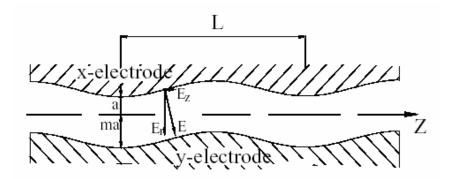
Outline

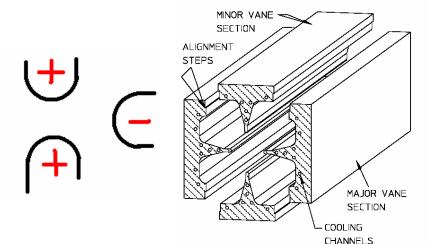
- RFQ R&D
- LEBT
- H- Ion Source
- Meson Installation
 - Blended into other sections



RFQ R&D

- RFQs are standard devices for H-Linacs (J-PARC, SNS).
 - Strong focusing
 - Beam Bunching
 - Acceleration 50 KeV to 2.5 MeV
 - Commercial manufacturing is routine
- An ANL FNAL collaboration produced:
 - FNAL document 5500-ES-371025
 - P. Ostroumov, V. N. Aseev and A.A.
 Kolomiets, IoP, 2006 JINST 1
 P04002







RFQ REQUIREMENTS

OPERATING REQUIREMENTS

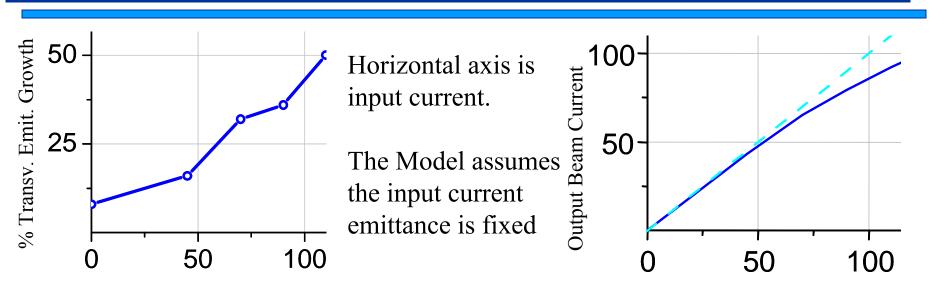
These parameters effect ion source and LEBT choices

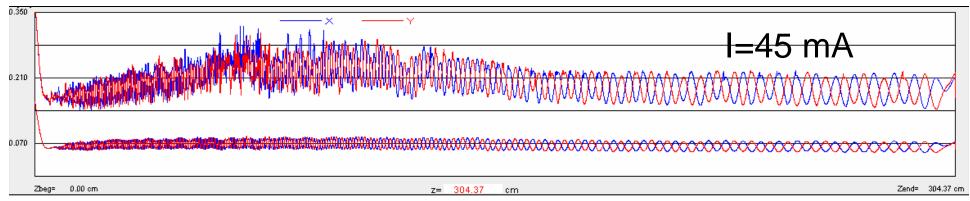
Halo free to reduce → beam losses

On anating Frages and	
Operating Frequency	325 MHz at nominal RF power and 27 °C ambient temp.
Input Energy	50 keV
Output Energy	2.5 MeV
Output Current (max)	40 mA bunched
Pulse Parameters	
Initial operation:	3 msec x 2.5 Hz @ 13 mA bunched (duty factor 0.75%)
Final operation:	1 msec x 10 Hz @ 40 mA bunched (duty factor 1 %)
Input Transverse Emittance	0.24π mm-mrad RMS Normalized
Output Transverse Emittance	0.26 π mm-mrad RMS Normalized
1	
Output Longitudinal Emittance	Less than 150 π keV deg, rms
	Less than 150 π keV deg, rms Axisymmetric: $\beta_x = \beta_y$, $\alpha_x = \alpha_y$ equal within +/-10%
Output Longitudinal Emittance	<u> </u>
Output Longitudinal Emittance Output Twiss parameters	Axisymmetric: $\beta_x = \beta_y$, $\alpha_x = \alpha_y$ equal within +/-10%
Output Longitudinal Emittance Output Twiss parameters Acceleration Efficiency	Axisymmetric: $\beta_x = \beta_y$, $\alpha_x = \alpha_y$ equal within +/-10% > 85% of incoming beam exits at >99% nominal energy
Output Longitudinal Emittance Output Twiss parameters Acceleration Efficiency Power Consumption (max)	Axisymmetric: $\beta_x = \beta_y$, $\alpha_x = \alpha_y$ equal within +/-10% > 85% of incoming beam exits at >99% nominal energy 450 kW(structure) + 100 kW (beam)
Output Longitudinal Emittance Output Twiss parameters Acceleration Efficiency Power Consumption (max) Sparking Rate	Axisymmetric: $\beta_x = \beta_y$, $\alpha_x = \alpha_y$ equal within +/-10% > 85% of incoming beam exits at >99% nominal energy 450 kW(structure) + 100 kW (beam) < 10^{-4} sparks/pulse



RFQ R&D – Beam Dynamics





Beam envelope along RFQ simulation (TRACK code), lower curves are beam RMS size, upper curves are beam envelopes for X and Y. Total particle loss is below 2%



RFQ – Prototype Procurement

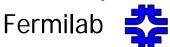
- Quote requests were sent to several manufacturing companies in ~Sept. 05
- Fermilab received several quotes in the ~0.5 M\$ range and production schedules ranging from 6-12 months.
- A 0.5 M\$ requisition was placed in Jan '06 and 3 bids were returned in March 06.
 - Companies had the option to adopt ANL/FNAL design or propose their own design meeting FNAL Beam specs.
 - Vacuum Chambers and Power Couplers were included in the order
 - Companies were also requested to provide quote for commissioning support
- Final vendor selection: May '06.
- Expected delivery to Meson area in 6 months (~Dec. '06)
- Installation and testing ~Jan. 07

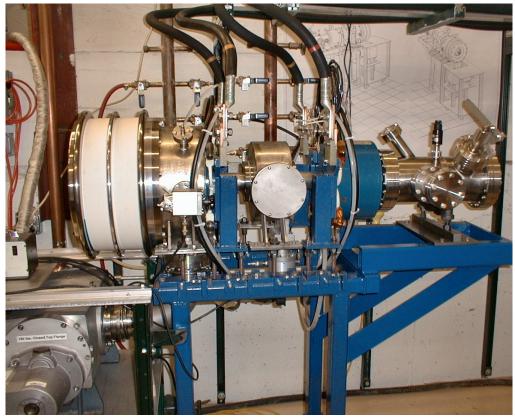


LEBT

- Acceleration and beam matching to RFQ and safety
 - 50 kV electrostatic acceleration
 - 2 solenoid lens provide matching to the RFQ.
 - Beam stop system for personnel safety (to be added)
- Decision: Adapt an old Fermilab Dualplasmatron system
 - Available in Y05
 - Substantial cost saving
 - Refurbished in MS6 by the TD
 - HV testing of the existing electrodes is complete
 - Beam transport tests using a
 Dualplasmatron (H+) ~
 May/June 06







H- Ion Source Requirements

• LEBT beam parameters modified from RFQ input parameters

- Beam current increased to account for losses in RFQ
- Pulse length increased to account for chopping

Output Energy	50 keV
Output Current (max)	45 mA DC
Pulse Parameters	
Initial operation:	3.1 msec x 2.5 Hz @ 15.3 mA DC (duty factor 0.77%)
Final operation:	1.1 msec x 10 Hz @ 47 mA DC (duty factor 1.1 %)
Output Transverse Emittance	0.24 π mm-mrad RMS Normalized
Output Twiss parameters	Axisymmetric: $\beta_x = \beta_y$, $\alpha_x = \alpha_y$ equal within +/-10%
Acceleration Efficiency	> 85% of incoming beam exits at >99% nominal energy

Ion source investigation and collaboration started in 2004

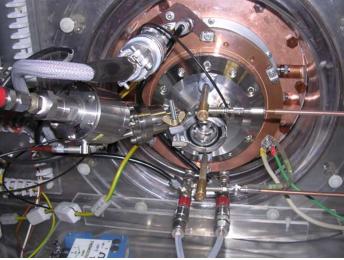
- SNS and DESY RF multicusp ion source
- FNAL and BNL magnetron ion source



Modern H⁻ Ion Source options?



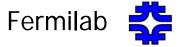
DESY H⁻ Source





SNS H⁻ source





DESY RF Multicusp Volume Source

- low duty factor (0.05-0.1%)
- External antenna (2MHz)
- Ignition: cold cathode in gas injection line
- No cesium
- Being adopted for SPL at CERN which is setting the stage for technology transfer
- CERN cost estimate is aprox. 450 k\$

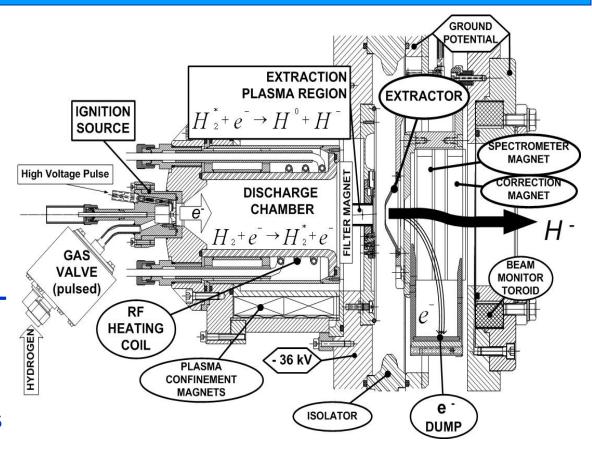
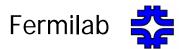


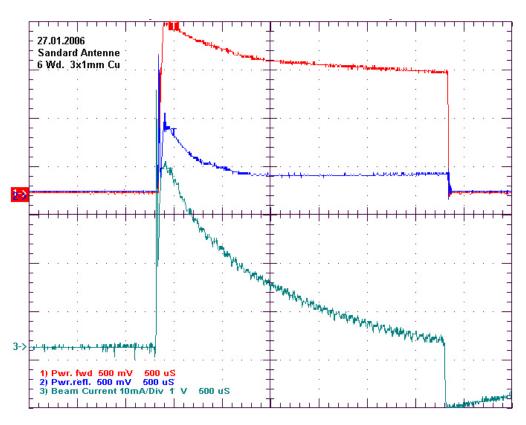
Figure provide by Jens Peters, DESY



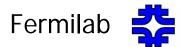
DESY RF Ion Source Testing

DESY site visit Jan. 06

- Droop in beam current due to limit of RF and extractor power supplies
- For higher duty factors heat loading would needs to studied
- Emittance (RMS, norm.) for 40 mA is aprox. 0.25 π mm-mrad.



Beam Current (10 mA and 500 µs / division), Forward and Reflected power ,operating at 0.5 Hz



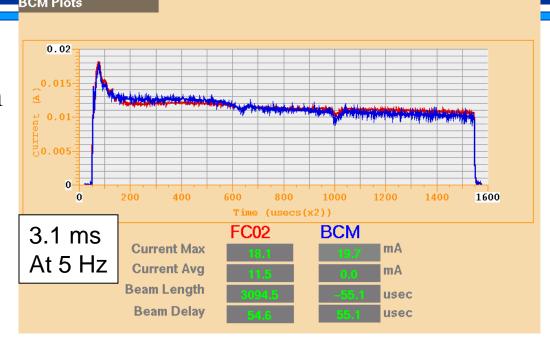
SNS RF Ion Source Testing

SNS site visit 2004 Informal collaboration established

Red: Faraday cup

Blue: Toroid with

Droop correction

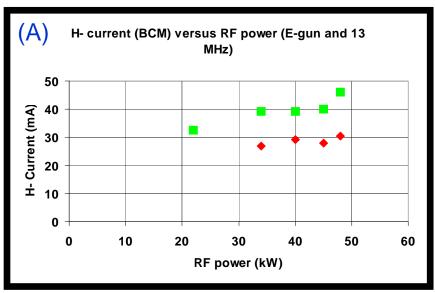


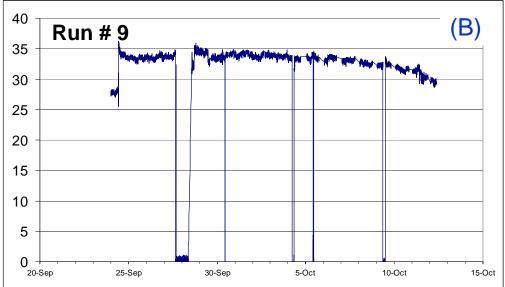
Tested 3.1 ms at 5 Hz and 65 KV extraction

- Beam current average of 11-12 mA at 30 kW OF 2 MHz RF
- Limited by average heat load of the primary RF amplifier
 - RF supply manufacturer indicated that this could easily be overcome
- An RF power ramp should also help compensate for the 1-2 mA droop in the pulse.



SNS Ion Source Development





- (A) Investigation of a hollow anode gas injection to provide extra electrons to the plasma
 - Short pulse, no cesium
- (B) Operation is still being optimized
 - 16 days with an average beam current of 33 mA and a 0.5 mA/day beam attenuation rate. 85 million pulses (1.2 ms, 60 Hz) only 5 trip





H- Ion Source for HINS in Meson

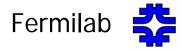
- Magnetron ion source selected based on <u>time</u>, <u>availability</u>, <u>cost and expertise</u>!!
 - This buys us time!
 - Other labs continue to push the RF multicusp source and are willing to let us participate and learn.

FNAL source

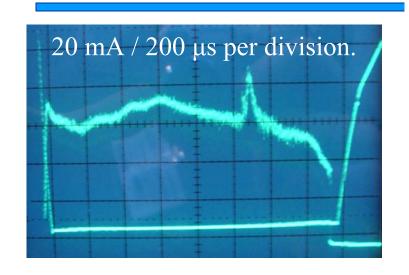








Magnetron Tests at BNL



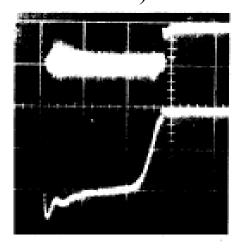
(right) BNL Mark III 1975:

– Multi-slit magnetron 350 mA!!!

-2.5 ms pulse, 0.1 Hz and 15 kV K. Prelec and Th. Sluyters, PAC 1975, pg 1662.

(left) BNL site visit Feb. 06

- Peak at 1.1 ms is artificial (LEBT solenoids turning off).
- -Droop associated with PS
- Test was to short to understand thermal effects
 (10 min. at 6 Hz)



ARC VOLTAGE 200 V/cm

ARC CURRENT 50 A/cm

typically 120 A total current



CALIBRATION (IOO mA)

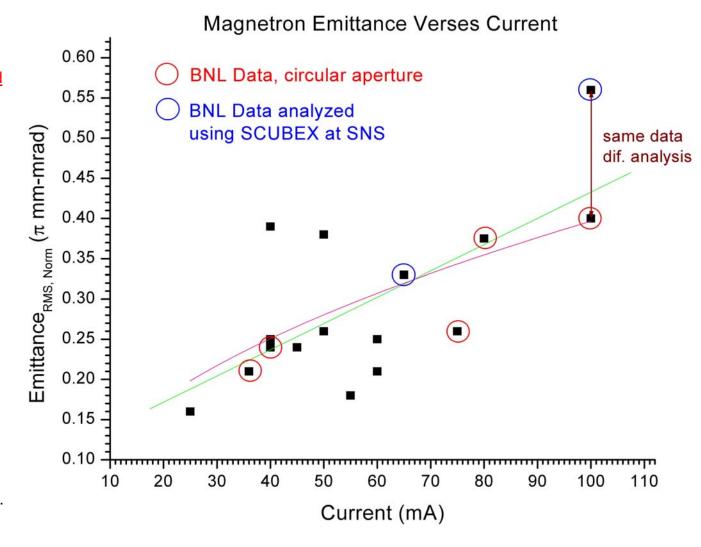
H⁻ OUTPUT

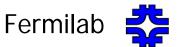


Magnetron Emittance?

Emittance Trend: No attempt to normalize or separate out cathode, aperture or LEBT/preaccelerator types. The green line is a linear fit to the data and the pink curve represents a square root fit to the data.

These emittance values were gleaned from the following reference: Schmidt, PNNIB, p.123 (1977) Alessi, PNNIB, AIP Conf. Proc. 158, 419 (1986) Stipp, IEEE TNS, 30, 2743 (1983)Smith, RSI 53, 405 (1982) Alessi talk associated with, AIP Conf. Proc. 642, 279 (2002) Criegee, Peters et al., RSI 62, 867 (1991) Schmidt, PNNIB, AIP Conf. Proc. 158, 425 (1986) Moehs, IEEE TPS, 33, 1786 (2005)Peters RSI 71, 1073 (2000) Welton, PNNIB, AIP Conf. Proc.

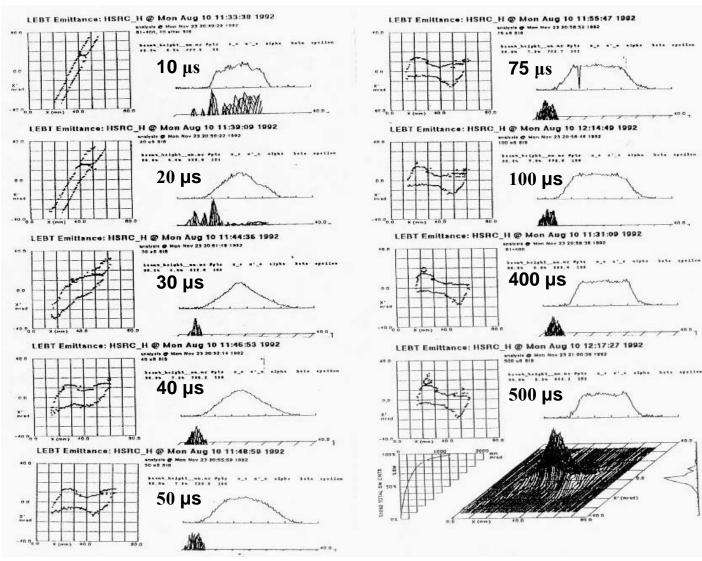


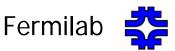


639, 160 (2002)

Emittance Evolution in the BNL LEBT

H- beam from the BNL circular aperture magnetron. After about 75 µs the emittance profile is more or less stable.



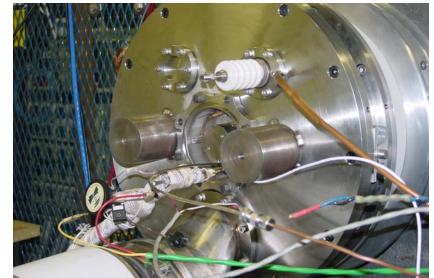


Ion Source Testing and Construction

Develop straight ahead variant on AD ion source test bench

~May-July 06

- Measure beam current
- Optimize anode aperture size
- Measure emittance
- Optimize magnetic field
- Test permanent magnet configuration
- Possible delay: ARC and Extraction
 PS from EE support



• H⁻ source installation in MS6 ~ Aug. 06

- Design ion source mounting and extraction electrodes for LEBT
- Measure beam current and transverse emittance
- Possible delay in the future: emittance at 45 mA is not low enough

Move completed system to Meson ~ Fall 06

Installation and connection to EPICs control system



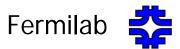
Cost Estimates: Ion Source and LEBT

• Y06 primarily in manpower

- Part modification and refurbishment
- Manufacture new Magnetron ion source components
- Infrastructure installation at Meson

• Y07 large items

- Redundant beam stop system for personnel safety
- SNS style emittance probes electronics and software



Conclusions

- H-Source: Our plan provides for a reliable ion source for the HINS test facility in Meson while allowing time for RF multicusp source advances which might make this source type a better choice for the HINS in the long term.
- RFQ: Using an RFQ for the initial acceleration stage of the HINS is common practice and commercial manufacturing is routine.

